

Electronic Patent Application Fee Transmittal

Application Number:	10576321			
Filing Date:	19-Apr-2006			
Title of Invention:	PROCESS FOR PRODUCING HIGH-RESISTANCE SILICON WAFERS AND PROCESS FOR PRODUCING EPITAXIAL WAFERS AND SOI WAFERS (AS AMENDED)			
First Named Inventor/Applicant Name:	Kazunari Kurita			
Filer:	Christopher W. Brody/Melissa Garton			
Attorney Docket Number:	12054-0059			
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1510	1510
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				1810